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ATTORNEY DOCKET NO. LMRX-P032/P1205

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: KIM et al  Serial No.: 10/804,430 (US Pat No. 7,078,350)  Filed: March 19, 2004 (Granted 7/18/2006)  Title: METHOD FOR THE OPTIMIZATION OF SUBSTRATE ETCHING IN A PLASMA PROCESSING SYSTEM	Group Art Unit: 1765  Examiner: UNASSIGNED  Confirmation No.: 7228	RECEIVED CENTRAL FAX CENTER AUG 04 2006
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I hereby certify that this paper or fee is being transmitted to the U.S. Patent Office on August 4, 2006 via facsimile transmission to fax number 571-273-8300. Total transmission: 11 pages.

Signed: /Alma Fazlic/  
Alma Fazlic

**INFORMATION DISCLOSURE STATEMENT**

Dear Sir:

The references listed in the attached PTO Form 1449 may be material to the patentability of the above-identified patent application. Applicants submit the list of these references in compliance with their duty of disclosure pursuant to 37 CFR §§ 1.56 and 1.97 and include a copy of the International Search Report and Written Opinion mailed May 15, 2006. The references listed therein also were cited by the U.S. Examiner in a prior Office Action.

The Examiner is requested to make these references of official record in this application. The information contained herein was first cited in a communication from a foreign patent office in a counterpart foreign application less than 3 months prior to the filing of this document.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

Applicant believes that no fees are due in connection with the filing of this Information Disclosure Statement. However, if it is determined that any fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 50-2284 (Order No. LMRX-P032).

Respectfully submitted,

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

<b>Form 1449 (Modified)</b>		Atty Docket No. <b>LMRX-P032/P1205</b>	Application No.: <b>10/804,430</b> <b>(US Pat No. 7,078,350)</b>
<b>Information Disclosure Statement By Applicant</b>		Applicant: <b>KIM et al</b>	Group <b>1765</b>
		Filing Date <b>March 19, 2004</b> <b>(Granted 7/18/2006)</b>	

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## US PATENT DOCUMENTS

Examiner Initials	No.	Document Number	Publication Date	Name of Patentee or Applicant	Reference to Related Case
1		US03/190807	10/09/2003	Soda et al.	
2		6,583,047	06/24/2003	Daniels et al.	
3		6/716,742	04/06/2004	Gates et al.	
4		US01/000246	04/12/2001	Tang et al.	

## Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No

## OTHER DOCUMENTS

Examiner Initials	No.		
5		PCT International Search Report mailed 05/15/2006, re PCT/US05/07886	
6		PCT Written Opinion mailed 05/15/2006, re PCT/US05/07886	

Examiner Signature		Date Considered	
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